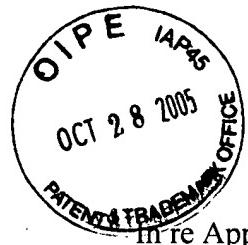


AF/DPW

Docket No.: 061282-0035

PATENT



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

**RESPONSE UNDER 37 C.F.R. 1.116
EXPEDITED PROCEDURE**

In re Application of : Customer Number: 20277
ITO, MITSUMI, et al. : Confirmation Number: 7469
Application No.: 10/634,988 : Group Art Unit: 2825
Filed: August 06, 2003 : Examiner: Stacy Whitmore

For: SEMICONDUCTOR DEVICE, METHOD OF GENERATING PATTERN FOR
SEMICONDUCTOR DEVICE, METHOD OF MANUFACTURING SEMICONDUCTOR
DEVICE AND DEVICE OF GENERATING PATTERN USED FOR SEMICONDUCTOR
DEVICE

REQUEST FOR RECONSIDERATION

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated July 28, 2005, having a three-month shortened statutory period for response set to expire on October 28, 2005, reconsideration of the above-identified application is respectfully requested in view of the following remarks.